

QCO.091A/061121

PATENT

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

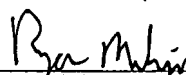
Applicant : Wen-Jian Lin
Appl. No. : 10/810,660
Filed : March 29, 2004
For : STRUCTURE OF A MICRO
ELECTRO MECHANICAL
SYSTEM AND THE
MANUFACTURING METHOD
THEREOF
Examiner : Jarrett J. Stark
Group Art Unit : 2823

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Ryan E. Melnick, Reg. No. 58,621

RESPONSE TO FINAL OFFICE ACTION

Mail Stop AF

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

In response to the Final Office Action mailed March 22, 2007, please find the enclosed remarks.

A Listing of the Claims begins on page 2 of this paper.

Remarks/Arguments begin on page 9 of this paper.